OPTIKA v 4.0 2022



Inverted trinocular brightfield/phase contrast microscope, IOS

Observation Method -	Brightfield	Yes
Transmitted Light	Phase contrast (Positive type)	Yes
	Darkfield	Yes
	Darkileiu	165
Main Body	Туре	Inverted
Wall bouy	Construction material	Aluminum die-cast
Head	Туре	Trinocular (Siedentopf)
	Split ratio	50/50
	Inclination	45°
	Interpupillary distance (mm)	50-75
	Fixing screw for eyepieces	Yes
	Tube inner diameter (mm)	30
Eyepieces	Field number (mm)	24
	Magnification	10x
	Planar type	Yes
	Micrometric scale	As optional
	Diameter of micrometer glass (mm)	26
	High eyepoint (for glass wearers)	Yes
	Diopter adjustment	Yes
	Rubber cup	Yes
	Retractable protections	Yes
Nosepiece	Positions	Quintuple
	Reversed	Yes
	Bi-directional	Yes
	Rotation on ball bearings	Yes
	Objective thread	RMS
Objectives	Optical system	∞
	Anti-fungus treatment	Yes
	Parfocal distance (mm)	45
	Standard magnifications	40x-600x
	Туре	IOS
		IOS LWD W-PLAN
		4x/0.13, W.D. 10.4 mm
		IOS LWD W-PLAN
		40x/0.60, W.D. 3.1 mm
		IOS LWD W-PLAN
		60x/0.70, W.D. 1.7 mm

		IOS LWD W-PLAN PH
		4x/0.13, W.D. 10.4 mm
		IOS LWD W-PLAN PH
		10x/0.25, W.D. 7.3 mm
		IOS LWD W-PLAN PH
		20x/0.40, W.D. 6.8 mm
		IOS LWD W-PLAN PH
		40x/0.65, W.D. 3 mm
		IOS LWD U-PLAN F
		4x/0.13, W.D. 18.52 mm
		IOS LWD U-PLAN F
		10x/0.30, W.D. 7.11 mm
		IOS LWD U-PLAN F
		20x/0.45, W.D. 5.91 mm
		IOS LWD U-PLAN F
		40x/0.65, W.D. 1.61 mm
		105 LWD U-PLAN F
		60x/0.75, W.D. 1.04 mm
		IOS LWD U-PLAN F PH
		20x/0.45, W.D. 5.91 mm
		IOS LWD U-PLAN F PH
		40x/0.65, W.D. 1.61 mm
-	-	
Stage	Туре	Fixed + Attachable mechanical stage
	Dimensions (mm)	215x250 (fixed stage)
		290x250 (with mechanical stage mounted)
	Moving mechanism	Rack and pinion
	Moving range (mm)	120x80
	Material	Anti-scratch painting
	Glass round insert	Yes
	Metal round insert	Yes
	Holder for Petri dish (mm)	38, 54, 65
	Holder for Terasaki plate	96 well
	Holder for 1 slide	Yes
	Holder for 2 slides	As optional
	Holder for Utermöhl chamber	As optional
	Holder for Utermohl chamber	As optional
Condenser - Single	Type	As optional Abbe
Condenser - Single Position		
-	Туре	Abbe
-	Type Removable	Abbe Yes
-	Type Removable Numerical aperture (N.A.) Diaphragm	Abbe Yes 0.50
-	Type Removable Numerical aperture (N.A.)	Abbe Yes 0.50 Iris
-	Type Removable Numerical aperture (N.A.) Diaphragm Slider for phase contrast Slider for darkfield (dry)	Abbe Yes 0.50 Iris BF, 4x/10x, 20x/40x positions
-	Type Removable Numerical aperture (N.A.) Diaphragm Slider for phase contrast Slider for darkfield (dry) Long working distance	Abbe Yes 0.50 Iris BF, 4x/10x, 20x/40x positions Yes
-	Type Removable Numerical aperture (N.A.) Diaphragm Slider for phase contrast Slider for darkfield (dry) Long working distance Working distance (for LWD) (mm)	Abbe Yes 0.50 Iris BF, 4x/10x, 20x/40x positions Yes Yes 28
-	Type Removable Numerical aperture (N.A.) Diaphragm Slider for phase contrast Slider for darkfield (dry) Long working distance Working distance (for LWD) (mm) Extendable working distance (for LWD) (mm)	Abbe Yes 0.50 Iris BF, 4x/10x, 20x/40x positions Yes Yes 28 up to 220
-	Type Removable Numerical aperture (N.A.) Diaphragm Slider for phase contrast Slider for darkfield (dry) Long working distance Working distance (for LWD) (mm) Extendable working distance (for LWD) (mm) Centrable	Abbe Yes 0.50 Iris BF, 4x/10x, 20x/40x positions Yes Yes 28 up to 220 Yes
-	Type Removable Numerical aperture (N.A.) Diaphragm Slider for phase contrast Slider for darkfield (dry) Long working distance Working distance (for LWD) (mm) Extendable working distance (for LWD) (mm)	Abbe Yes 0.50 Iris BF, 4x/10x, 20x/40x positions Yes Yes 28 up to 220
Position	Type Removable Numerical aperture (N.A.) Diaphragm Slider for phase contrast Slider for darkfield (dry) Long working distance Working distance (for LWD) (mm) Extendable working distance (for LWD) (mm) Centrable Focusable	Abbe Yes 0.50 Iris BF, 4x/10x, 20x/40x positions Yes Yes 28 up to 220 Yes By rack and pinion
-	Type Removable Numerical aperture (N.A.) Diaphragm Slider for phase contrast Slider for darkfield (dry) Long working distance Working distance (for LWD) (mm) Extendable working distance (for LWD) (mm) Centrable Focusable	Abbe Yes 0.50 Iris BF, 4x/10x, 20x/40x positions Yes Yes Yes 28 up to 220 Yes By rack and pinion Coaxial coarse & fine
Position	TypeRemovableNumerical aperture (N.A.)DiaphragmSlider for phase contrastSlider for darkfield (dry)Long working distanceWorking distance (for LWD) (mm)Extendable working distance (for LWD) (mm)CentrableFocusableTypeFine total travel (per single rotation) (mm)	Abbe Yes 0.50 Iris BF, 4x/10x, 20x/40x positions Yes Yes 28 up to 220 Yes By rack and pinion Coaxial coarse & fine 0,2
Position	TypeRemovableNumerical aperture (N.A.)DiaphragmSlider for phase contrastSlider for darkfield (dry)Long working distanceWorking distance (for LWD) (mm)Extendable working distance (for LWD) (mm)CentrableFocusableTypeFine total travel (per single rotation) (mm)Fine graduations	Abbe Yes 0.50 Iris BF, 4x/10x, 20x/40x positions Yes Yes Yes 28 up to 220 Yes By rack and pinion Coaxial coarse & fine 0,2 100
Position	TypeRemovableNumerical aperture (N.A.)DiaphragmSlider for phase contrastSlider for darkfield (dry)Long working distanceWorking distance (for LWD) (mm)Extendable working distance (for LWD) (mm)CentrableFocusableTypeFine total travel (per single rotation) (mm)Fine graduationsFine resolution (μm)	Abbe Yes 0.50 Iris BF, 4x/10x, 20x/40x positions Yes Yes 28 up to 220 Yes By rack and pinion Coaxial coarse & fine 0,2 100 2
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Position	TypeRemovableNumerical aperture (N.A.)DiaphragmSlider for phase contrastSlider for darkfield (dry)Long working distanceWorking distance (for LWD) (mm)Extendable working distance (for LWD) (mm)CentrableFocusableTypeFine total travel (per single rotation) (mm)Fine graduationsFine resolution (μm)	Abbe Yes 0.50 Iris BF, 4x/10x, 20x/40x positions Yes Yes 28 up to 220 Yes By rack and pinion Coaxial coarse & fine 0,2 100 2
Position Focusing System	TypeRemovableNumerical aperture (N.A.)DiaphragmSlider for phase contrastSlider for darkfield (dry)Long working distanceWorking distance (for LWD) (mm)Extendable working distance (for LWD) (mm)CentrableFocusableTypeFine total travel (per single rotation) (mm)Fine resolution (μm)Upper stop to prevent contactAdjustable tension	Abbe Yes 0.50 Iris BF, 4x/10x, 20x/40x positions Yes Yes 28 up to 220 Yes By rack and pinion Coaxial coarse & fine 0,2 100 2 Yes Yes Yes Yes Yes Yes
Position Focusing System	TypeRemovableNumerical aperture (N.A.)DiaphragmSlider for phase contrastSlider for darkfield (dry)Long working distanceWorking distance (for LWD) (mm)Extendable working distance (for LWD) (mm)CentrableFocusableTypeFine total travel (per single rotation) (mm)Fine graduationsFine resolution (μm)Upper stop to prevent contactAdjustable tensionKohler illumination	Abbe Yes 0.50 Iris BF, 4x/10x, 20x/40x positions Yes Yes Yes 28 up to 220 Yes By rack and pinion Coaxial coarse & fine 0,2 100 2 Yes Full
Position Focusing System	TypeRemovableNumerical aperture (N.A.)DiaphragmSlider for phase contrastSlider for darkfield (dry)Long working distanceWorking distance (for LWD) (mm)Extendable working distance (for LWD) (mm)CentrableFocusableTypeFine total travel (per single rotation) (mm)Fine graduationsFine resolution (μm)Upper stop to prevent contactAdjustable tensionKohler illuminationType	Abbe Yes 0.50 Iris BF, 4x/10x, 20x/40x positions Yes Yes 28 up to 220 Yes By rack and pinion Coaxial coarse & fine 0,2 100 2 Yes Yes Yes Full X-LED
Position Focusing System	TypeRemovableNumerical aperture (N.A.)DiaphragmSlider for phase contrastSlider for darkfield (dry)Long working distanceWorking distance (for LWD) (mm)Extendable working distance (for LWD) (mm)CentrableFocusableTypeFine total travel (per single rotation) (mm)Fine graduationsFine resolution (μm)Upper stop to prevent contactAdjustable tensionKohler illuminationTypeX-LED type	Abbe Yes 0.50 Iris BF, 4x/10x, 20x/40x positions Yes Yes 28 up to 220 Yes By rack and pinion Coaxial coarse & fine 0,2 100 2 Yes Yes Full X-LED X-LED8
Position Focusing System	TypeRemovableNumerical aperture (N.A.)DiaphragmSlider for phase contrastSlider for darkfield (dry)Long working distanceWorking distance (for LWD) (mm)Extendable working distance (for LWD) (mm)CentrableFocusableTypeFine total travel (per single rotation) (mm)Fine graduationsFine resolution (μm)Upper stop to prevent contactAdjustable tensionKohler illuminationType	Abbe Yes 0.50 Iris BF, 4x/10x, 20x/40x positions Yes Yes 28 up to 220 Yes By rack and pinion Coaxial coarse & fine 0,2 100 2 Yes Yes Yes Full X-LED

		65.000
	Lifetime (hours)	> 65,000
	Temperature (K)	6,300
	Max. required power (W)	13
Power Supply for	Туре	External
Transmitted	Microscope connector	Jack, 2.1 mm
Illumination	Power plug type	Multi-plug (EU, UK, US)
	Input voltage	100/240 Vac, 50/60 Hz
	Output voltage	12 Vdc 5 A
	ECO function	Yes
	LED indicator	Yes
Accessories Included	Dust cover	Yes
	Allen wrench	Yes
	Centering telescope	Yes
	Green filter	Yes
	LBD filter	Yes
	User Manual	Digital version (downloadable)
Product Dimensions	Height (mm)	545
	Width (mm)	290
	Depth (mm)	560
Product Weight	(kg)	10



Pricing on any accessories shown can be found by keying the part number into the search box on our website. The specifications listed in this brochure are subject to change by the manufacturer and therefore cannot be guaranteed to be correct. If there are aspects of the specification that must be guaranteed, please provide these to our sales team so that details can be confirmed.

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